



IR AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

MONA M. EISSA

Serial No. 10/621,879 (TI-28394.1)

Filed July 17, 2003

For: EFFECTIVE SOLUTION AND PROCESS TO WET-ETCH
METAL-ALLOY FILMS I SEMICONDUCTOR PROCESSING

Art Unit 1765

Examiner Kin-Chan Chen

Customer No. 23494

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING OR TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that the attached document is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to Director of the United States Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450 or is being facsimile transmitted on the date indicated below:

10-17-05

Jay M. Cantor

Jay M. Cantor, Reg. No. 19,906

AMENDMENT UNDER 37 C.F.R. 1.116

In response to the Office action dated August 29, 2005, please amend the above-identified application as follows: